

Receipt date: 02/21/2006

10564972 - GAU: 1795



PTO/SB/08b (07-05)
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				Application Number	10/564,972
				Filing Date	January 18, 2006
				First Named Inventor	ZAIT, Eitan
				Art Unit	Not yet assigned
				Examiner Name	Not yet assigned
Sheet	1	of	1	Attorney Docket Number	P-8503-US

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (where appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-Issue number(s), publisher, city and/or country where published.	T ²
/S.F./	A	Jong Rak Park et al, "Improvement of Shot Uniformity on a Wafer by Controlling Backside Transmittance Distribution of a Photomask", Optical Microlithography, Proceedings of SPIE, Vol 5040, 2003, pp 553-560	<input type="checkbox"/>
/S.F./	B	Alfred Kwok-Kit Wong, "Resolution Enhancement Techniques in Optical Lithography", SPIE Press 2001, Chapter 1 3 4, pp 18-23	<input type="checkbox"/>
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